

10/584729

1AP20 Rec'd PCT/P10 23 JUN 2006
Attorney Docket No. 0756-7709

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Koichiro TANAKA et al.) Attention: DO/EO/US
Based On: PCT/JP2005/019456)
Filed On: October 18, 2005)
For: LASER IRRADIATION METHOD,)
LASER IRRADIATION APPARATUS)
AND METHOD FOR)
MANUFACTURING)
SEMICONDUCTOR DEVICE)

PRELIMINARY AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the above-identified application before calculation of the government claim fees.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 10 of this paper.